



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi SERA

Group Art Unit: 2813

Application No.: 10/826,366

Examiner: C. RODGERS

Filed: April 19, 2004

Docket No.: 119209

For: METHOD FOR MAKING THIN-FILM
SEMICONDUCTOR DEVICE, THIN-FILM
SEMICONDUCTOR DEVICE, METHOD FOR
MAKING ELECTRO-OPTIC APPARATUS,
ELECTRO-OPTIC APPARATUS, AND
ELECTRONIC APPARATUSES

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)
continued examination.

☒ Applicant(s) further request(s) entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 183467 in the amount of ☒ \$790.00 as payment of the fees
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two
duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

James E. Golladay, II
Registration No. 58,182

JAO:JEG/tls

Date: August 25, 2006

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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